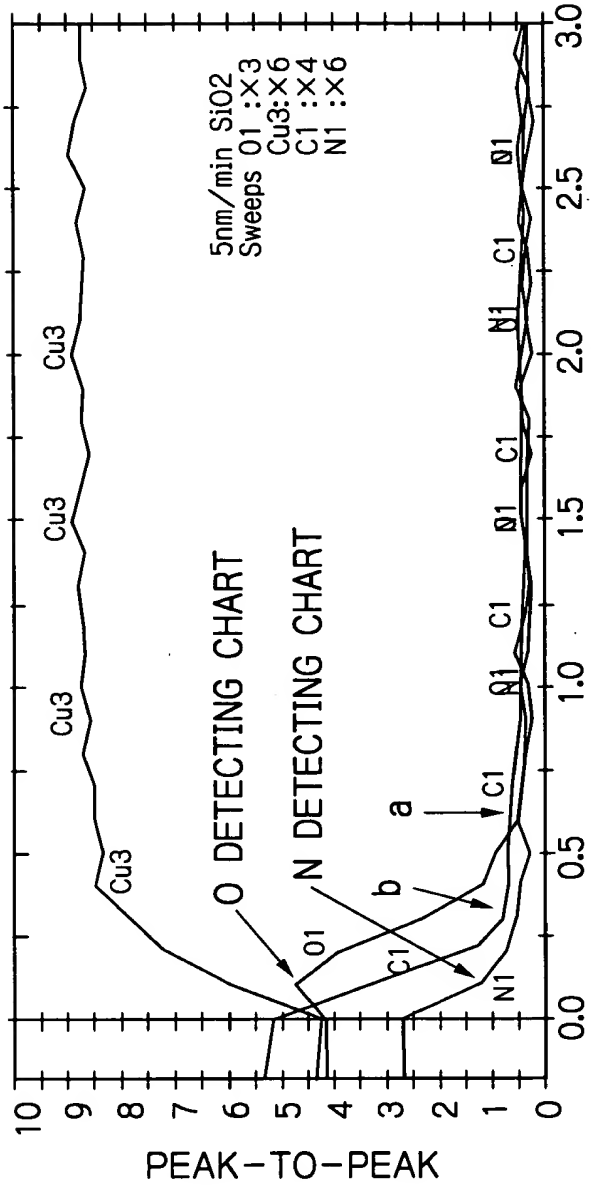
Fig. 1


5nm/min SiO2
Sweeps O1 :×3
Cu3:×6
C1 :×4
N1 :×6
O DETECTING CHART
N DETECTING CHART
Cu3
O1
C1
N1
a
b
PEAK-TO-PEAK
SPUTTER TIME, min.
PROFILE IN THICKNESS DIRECTION